

Fig. 6 A Large Ratio of te/tp

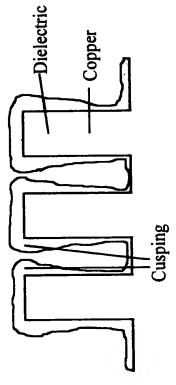
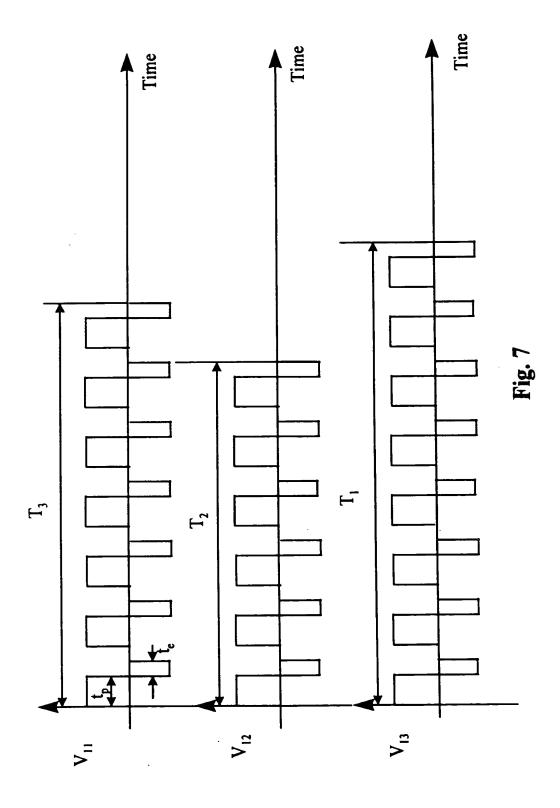
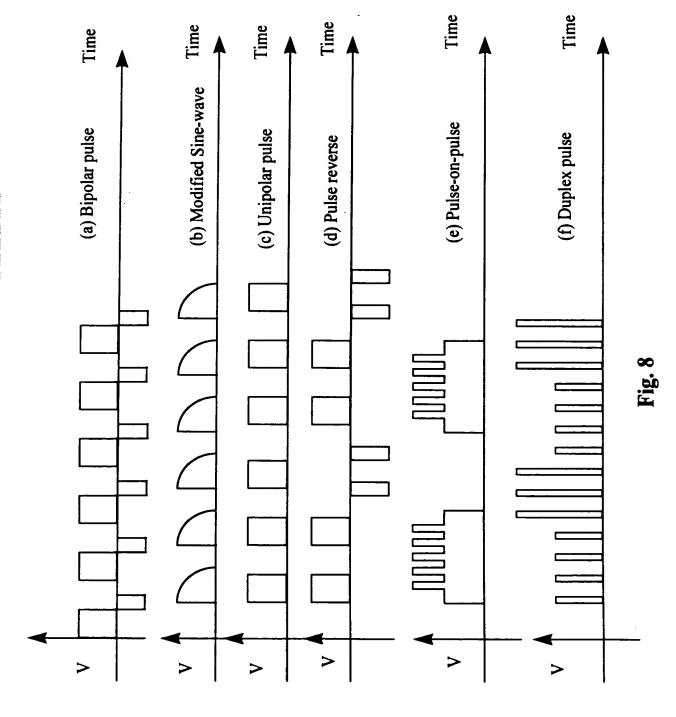


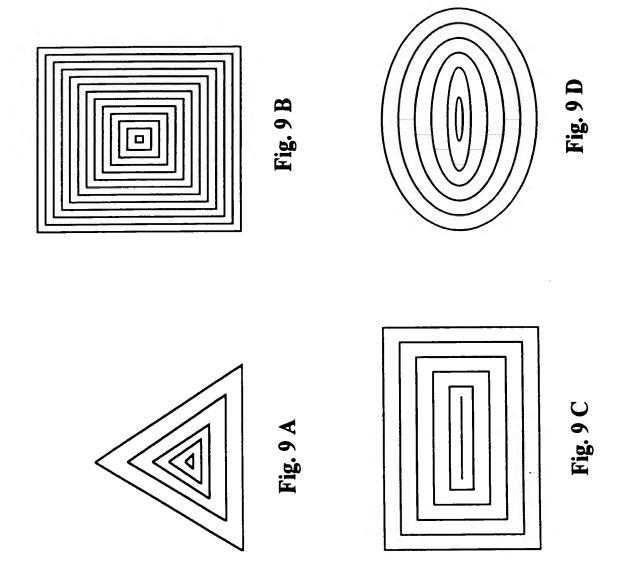
Fig. 6 B Small Ratio of te/tp

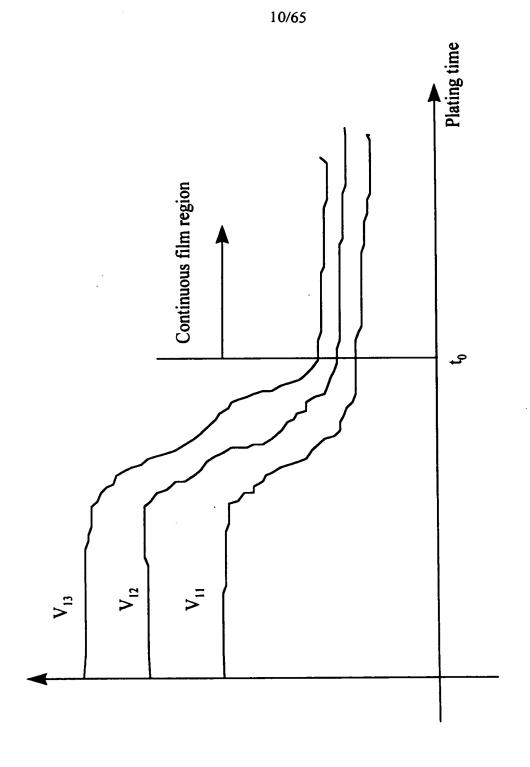






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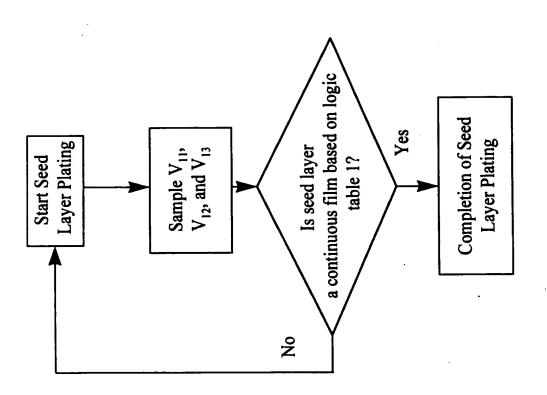
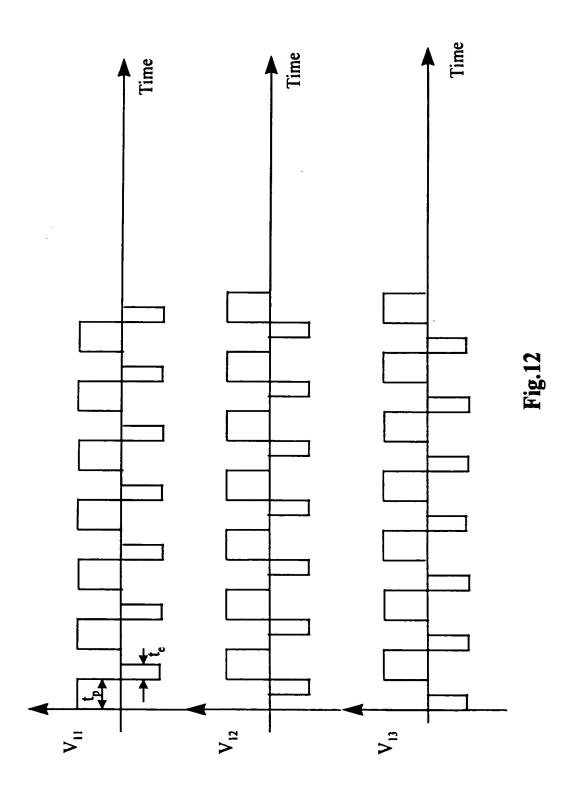
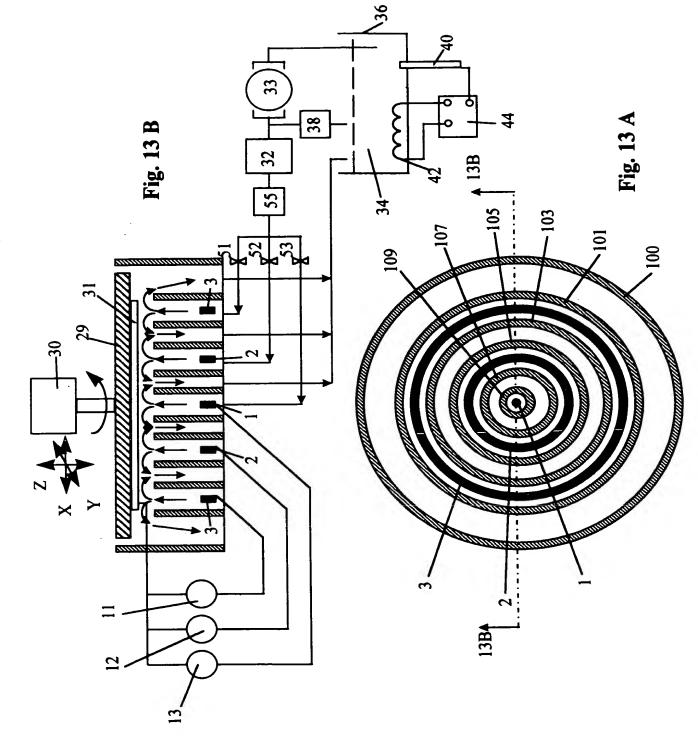


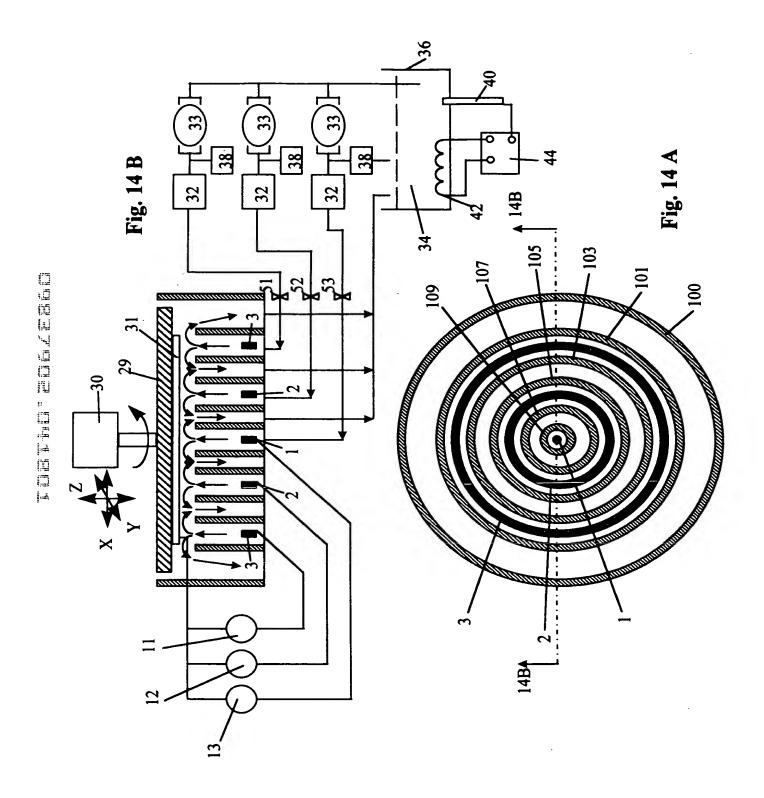
Fig. 11

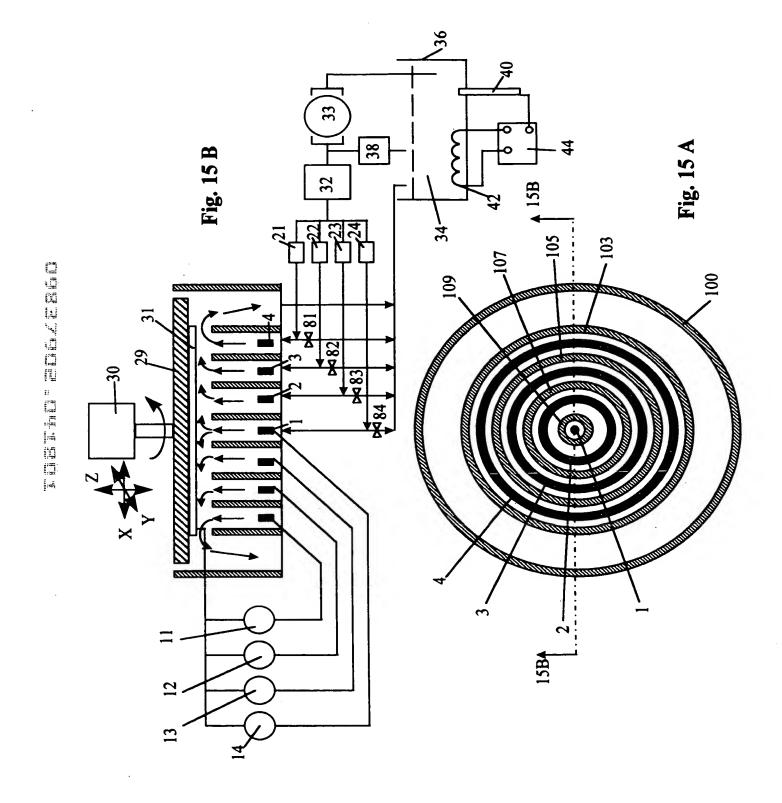


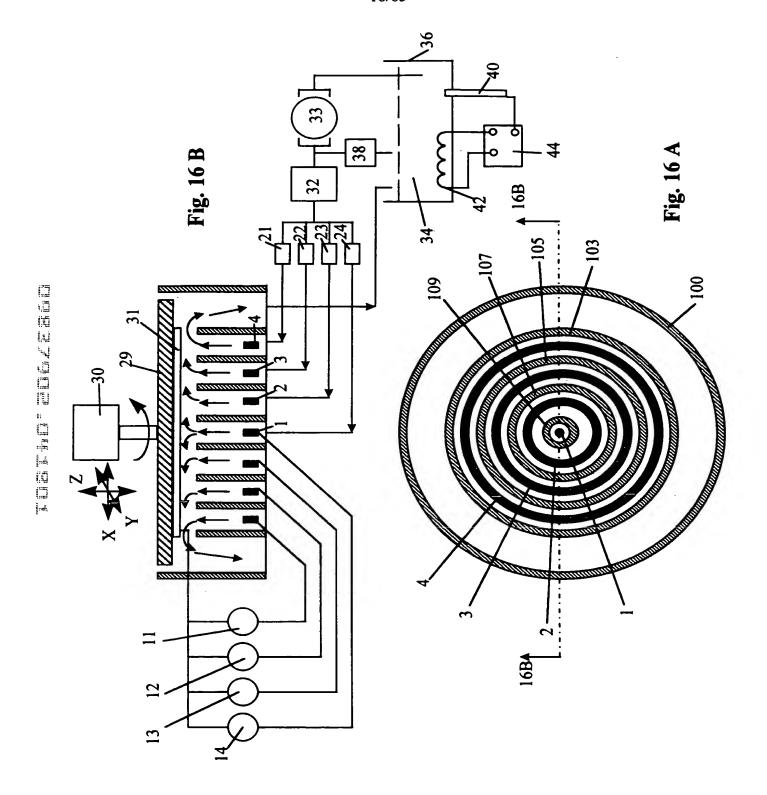


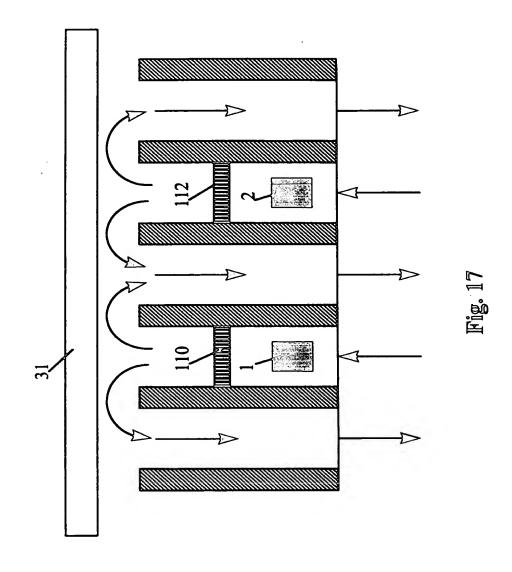


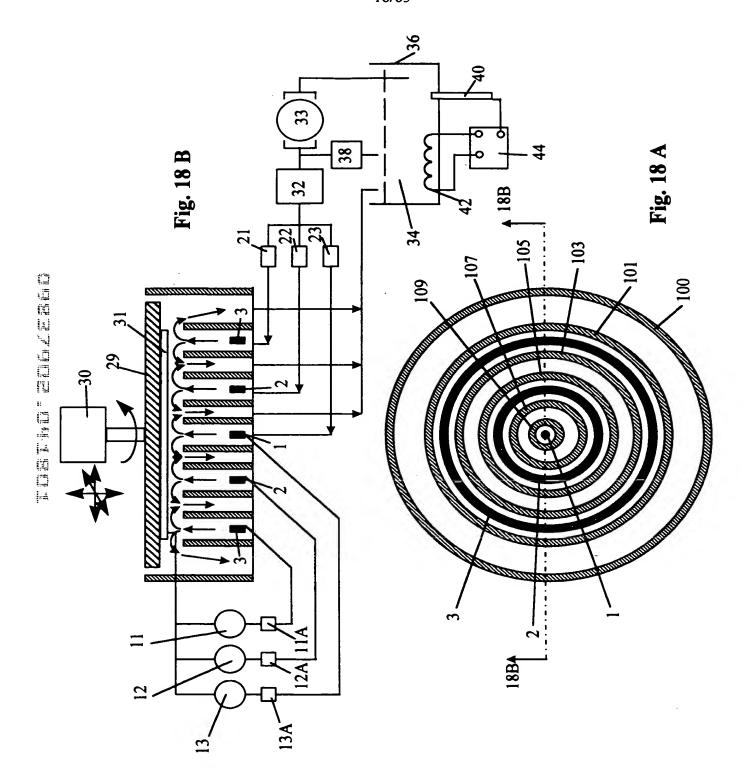
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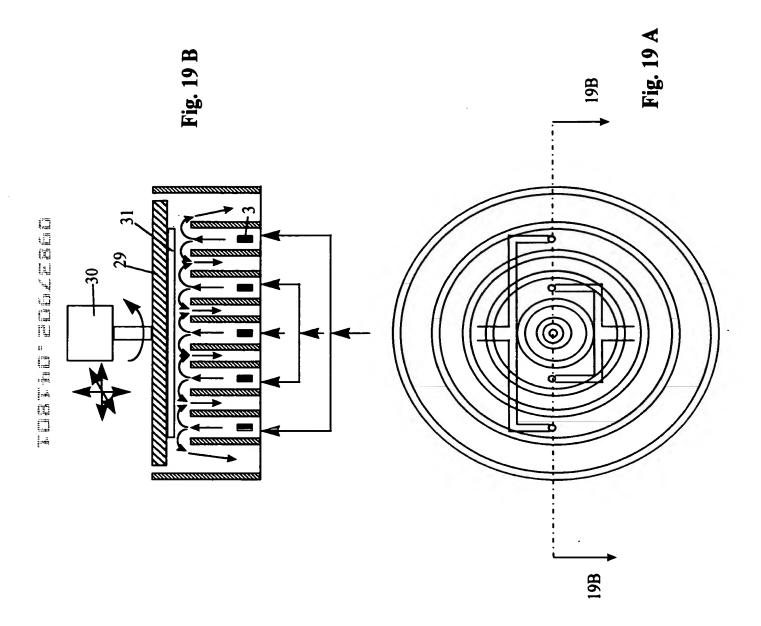


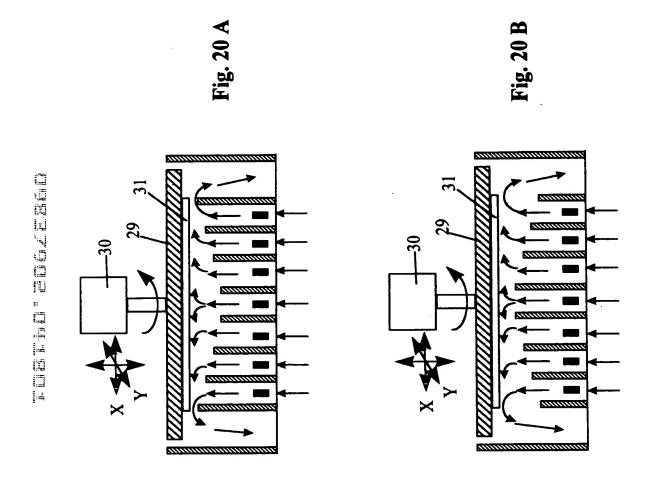


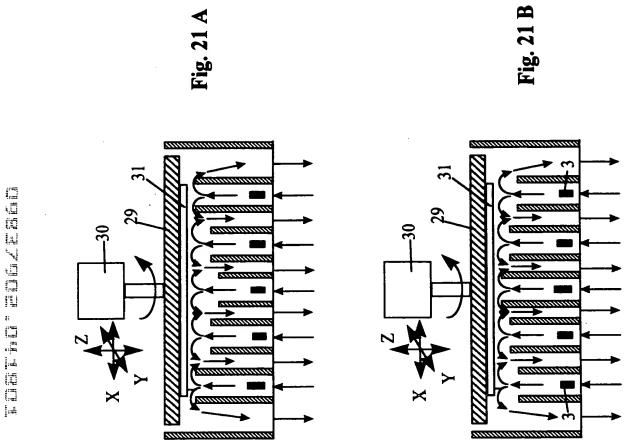


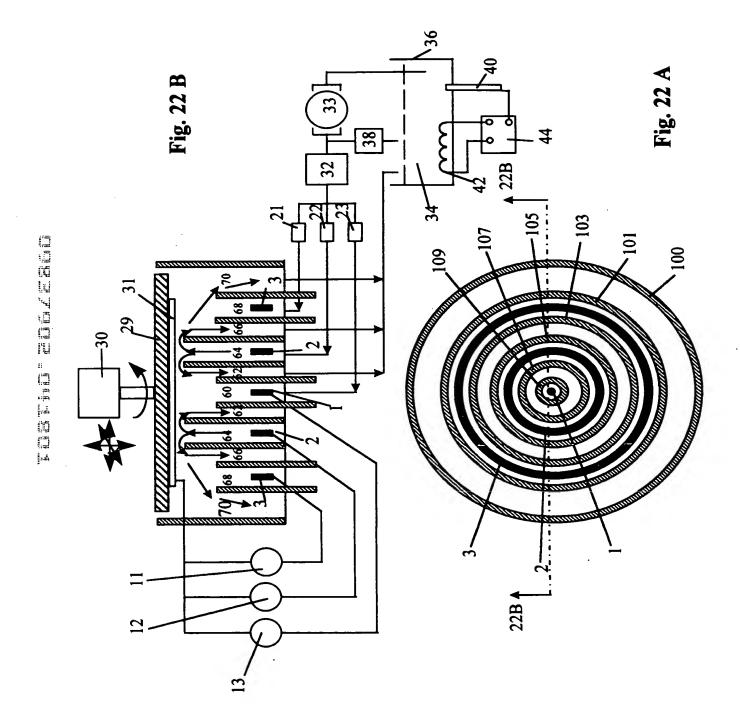


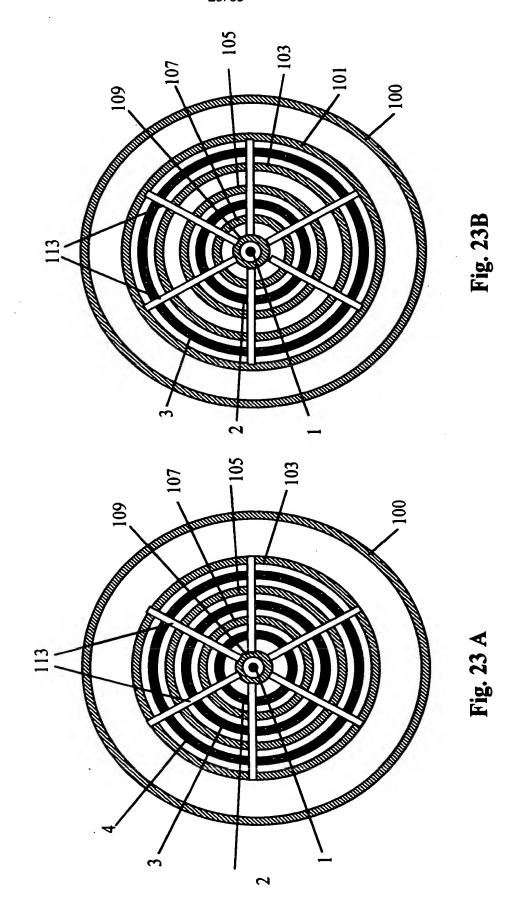


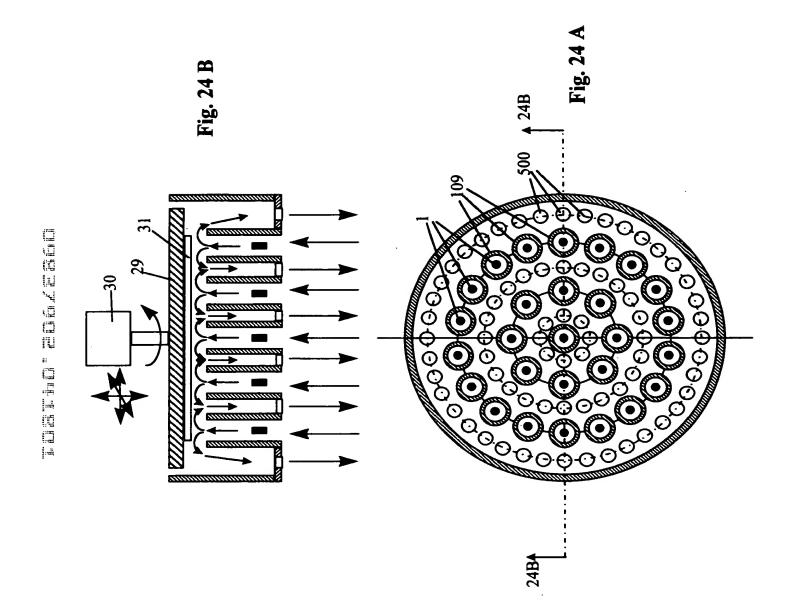


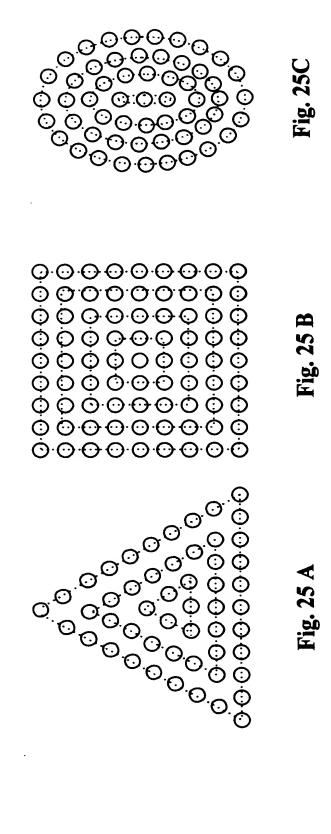


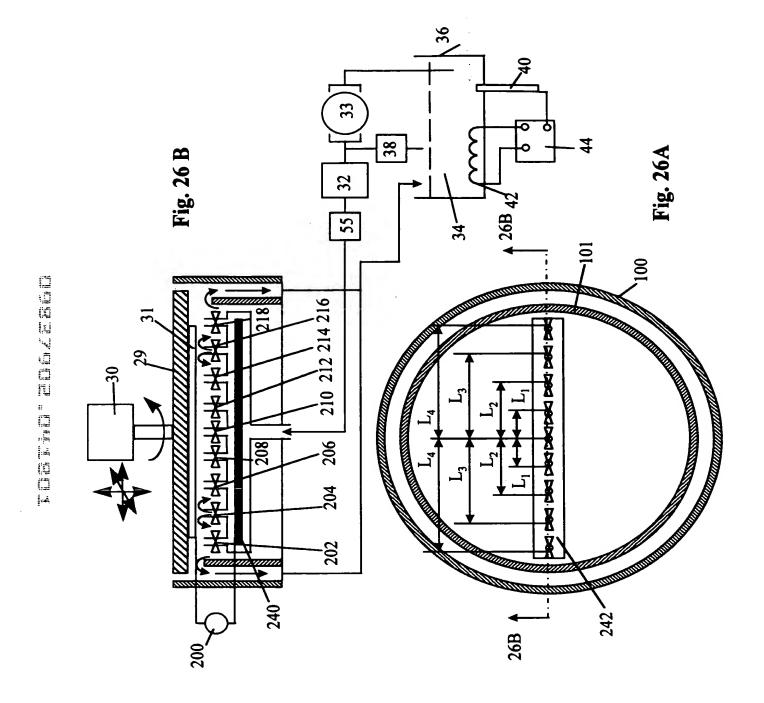


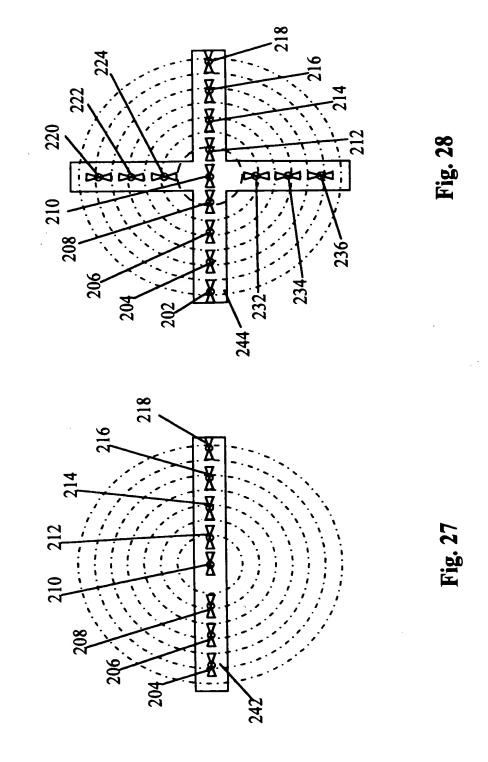


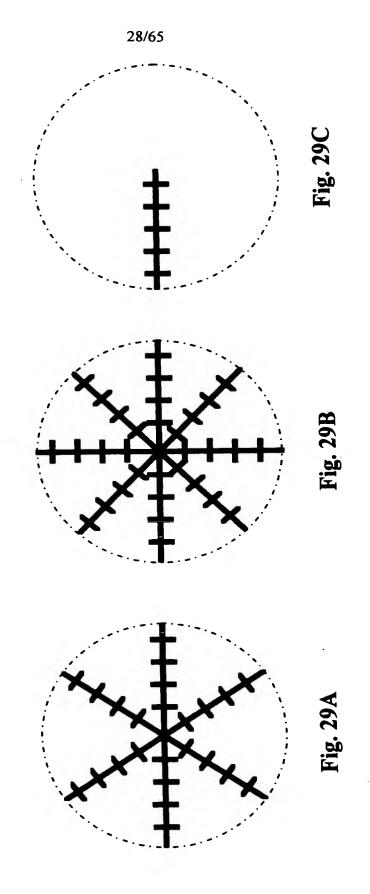


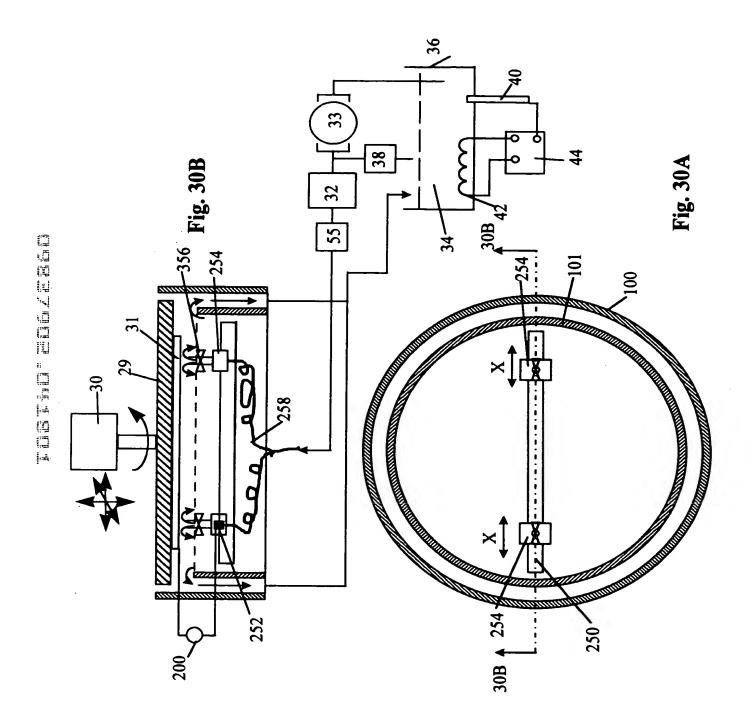


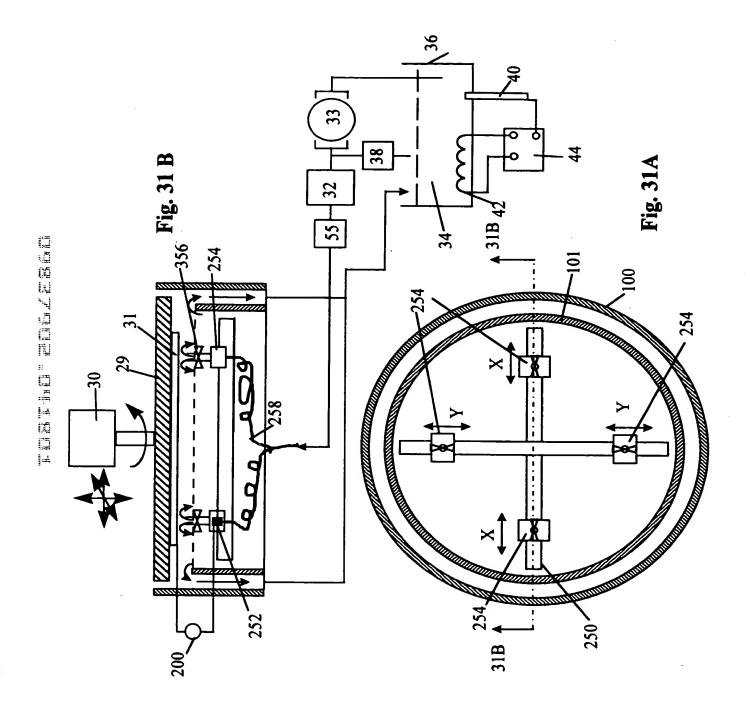


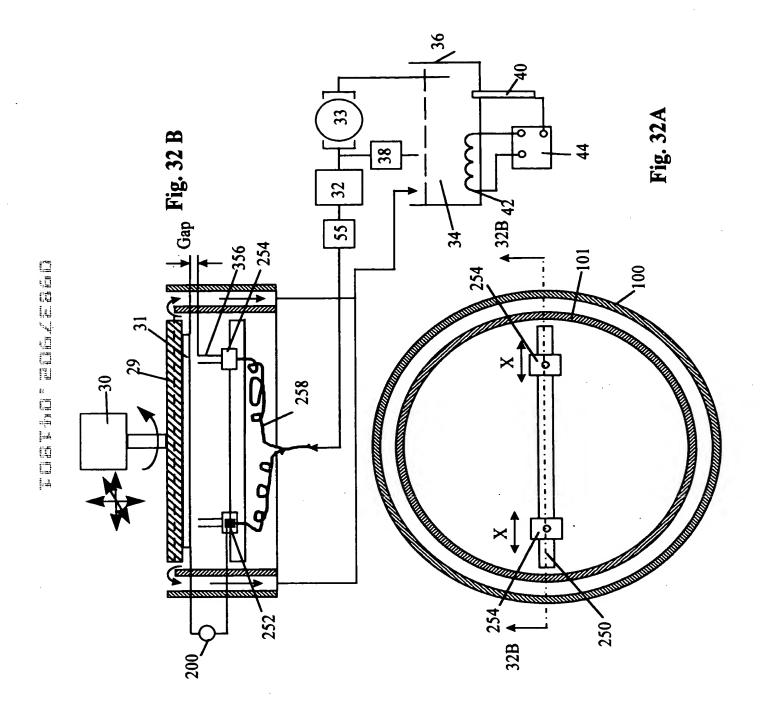


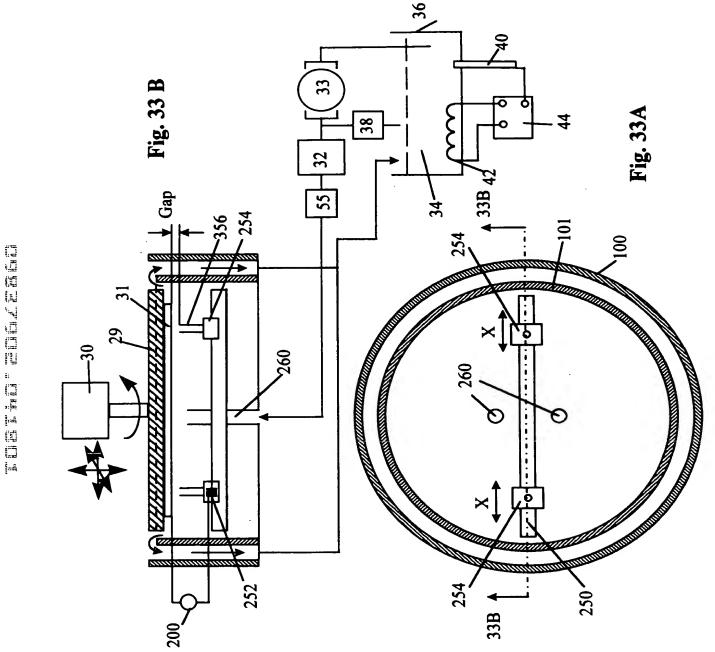


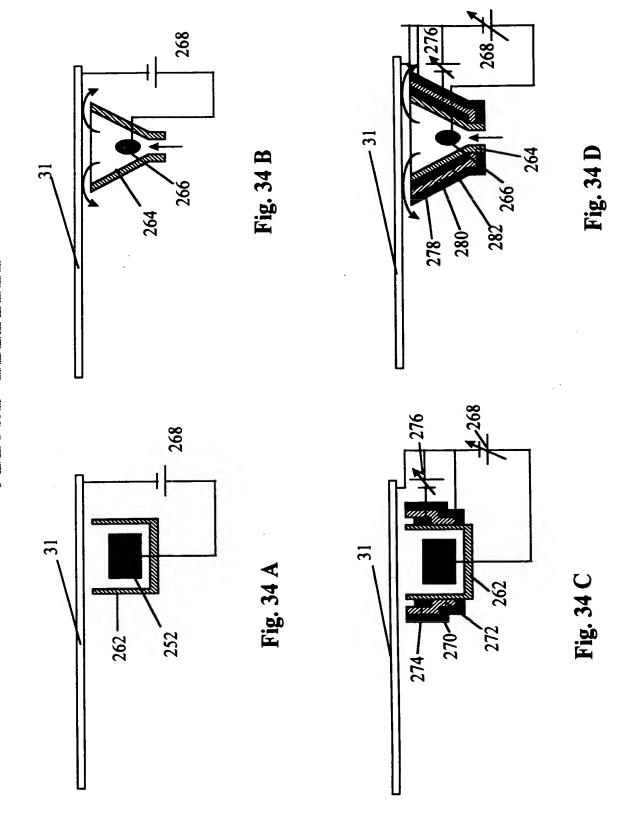






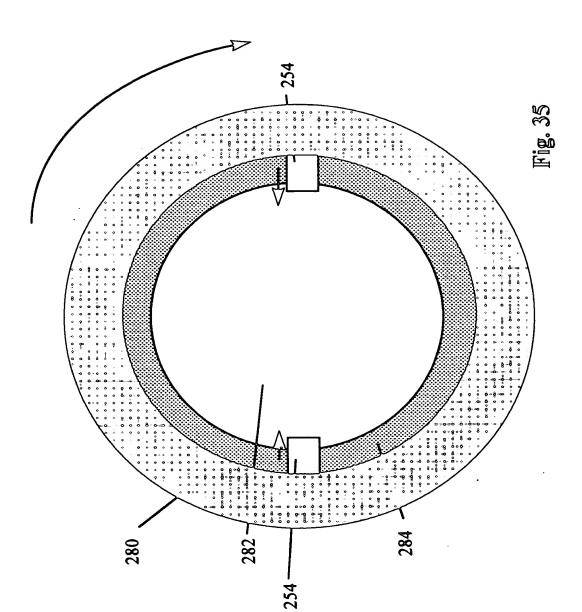


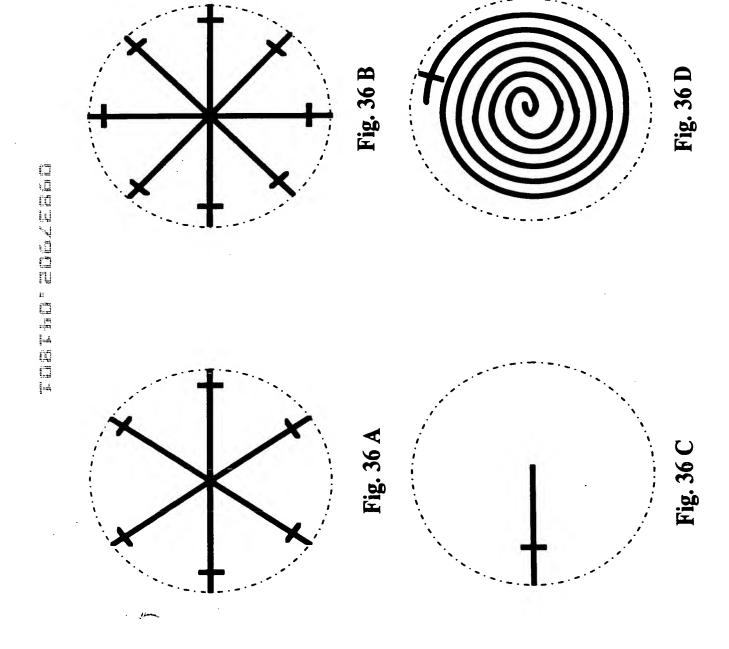


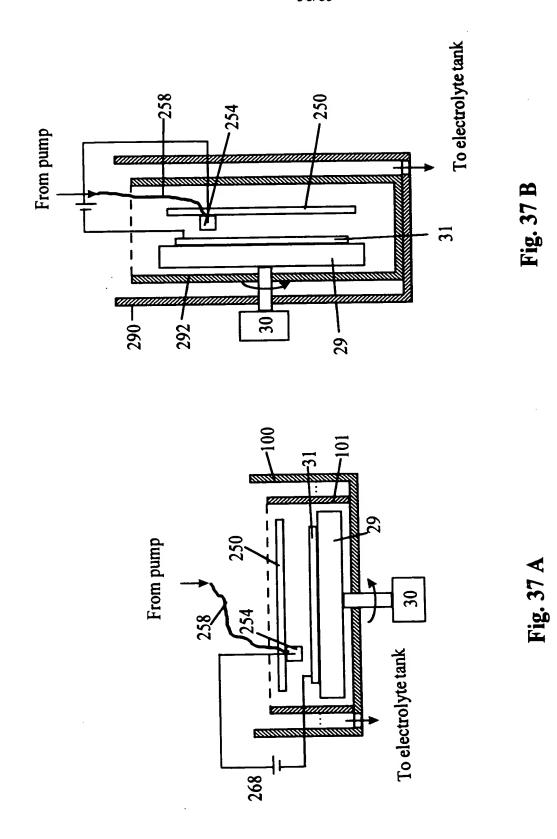


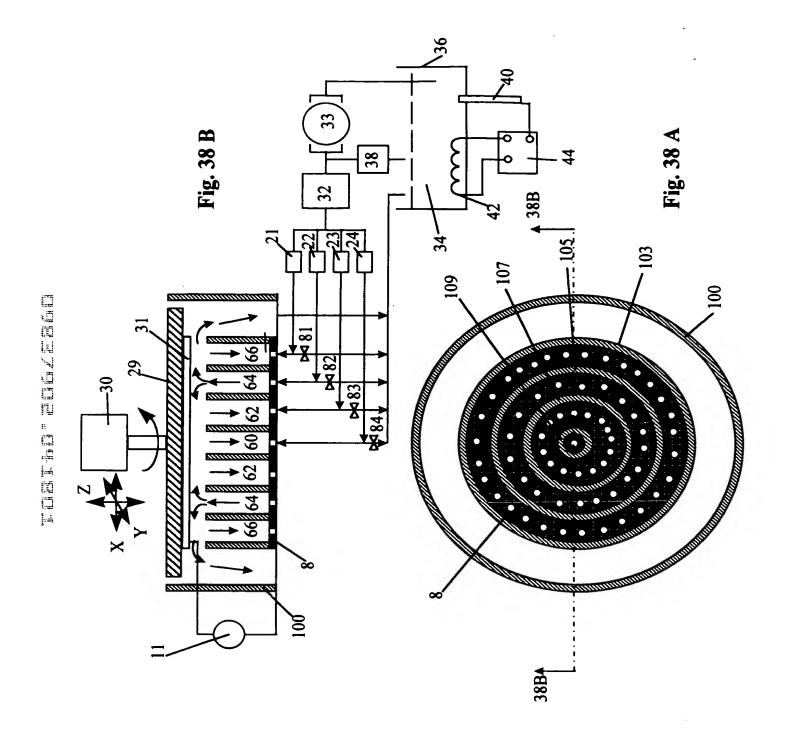
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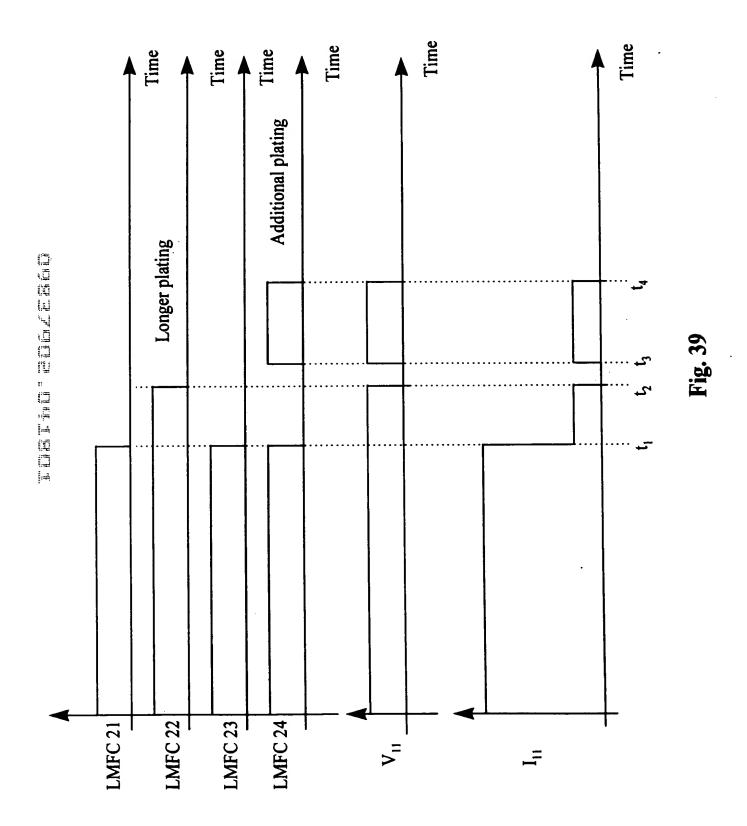


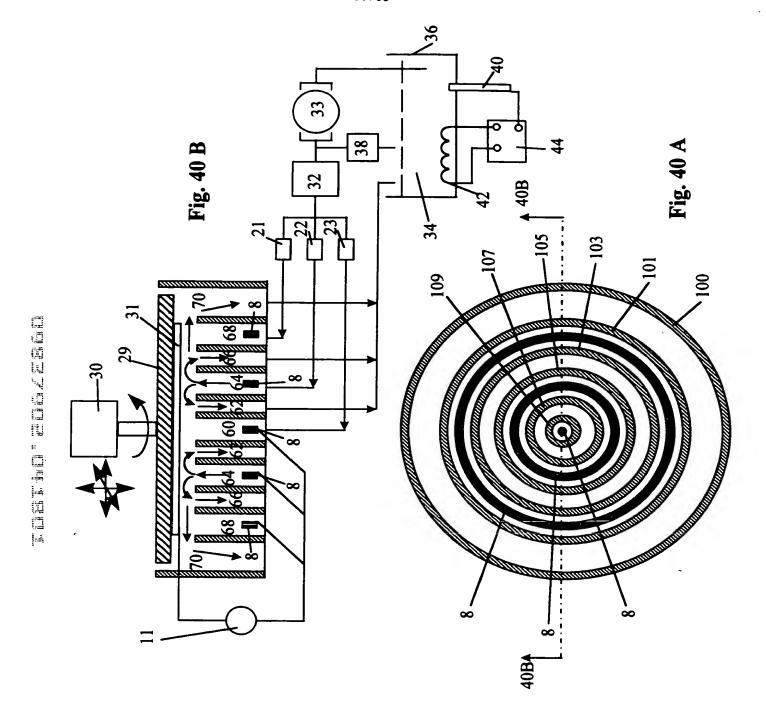


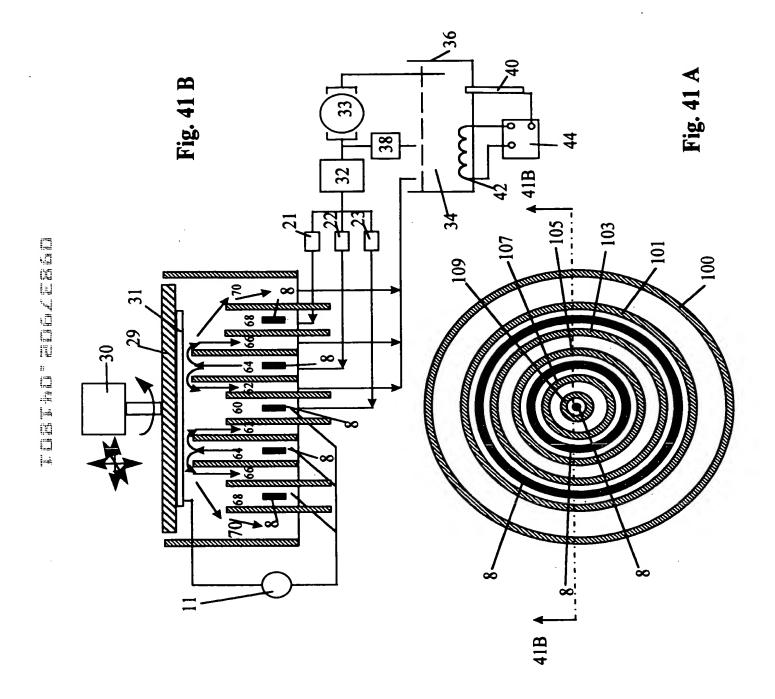


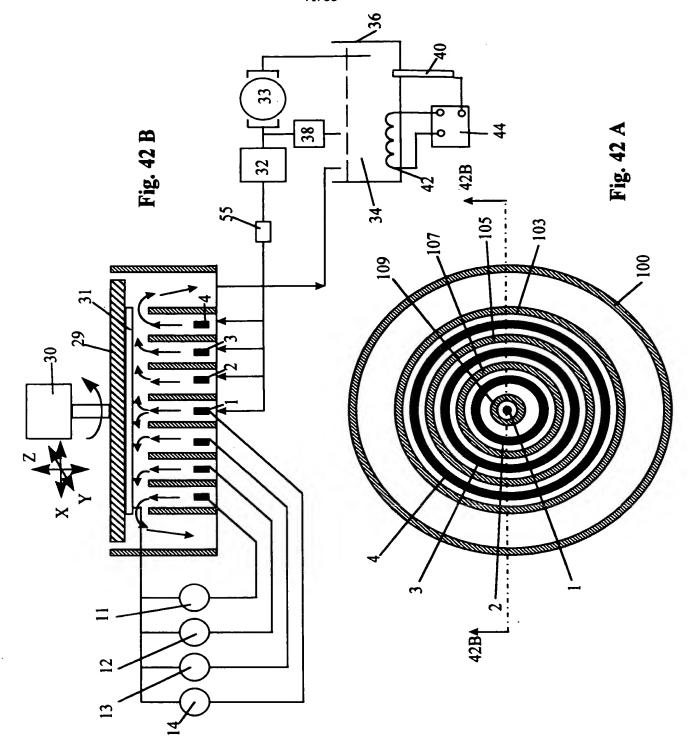












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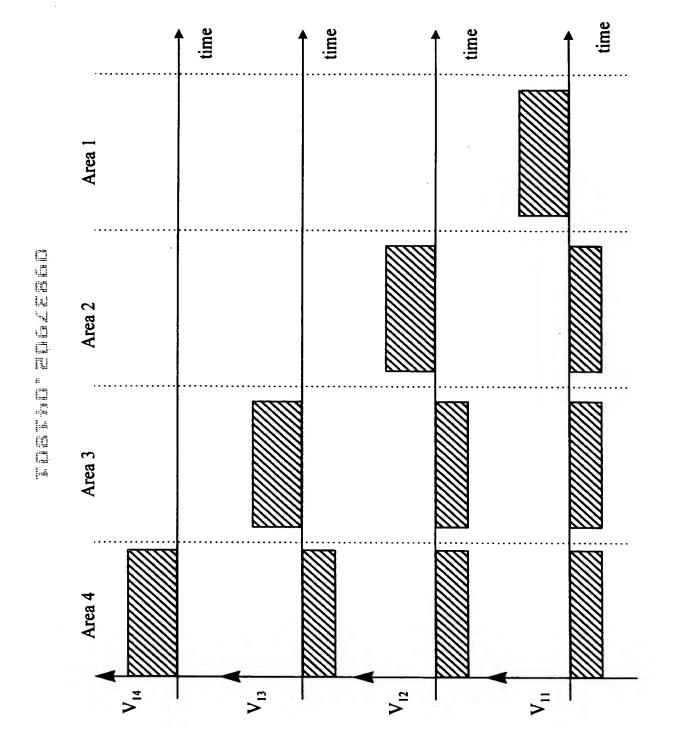
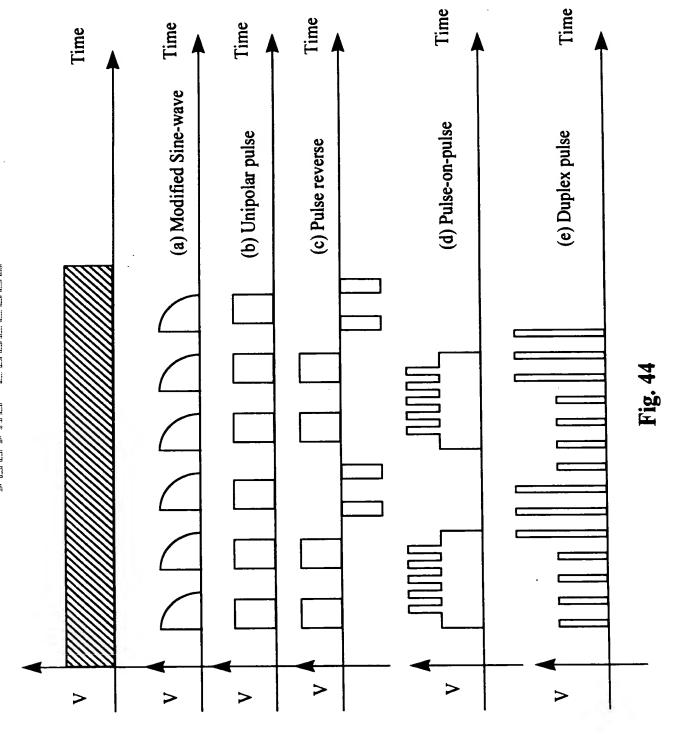
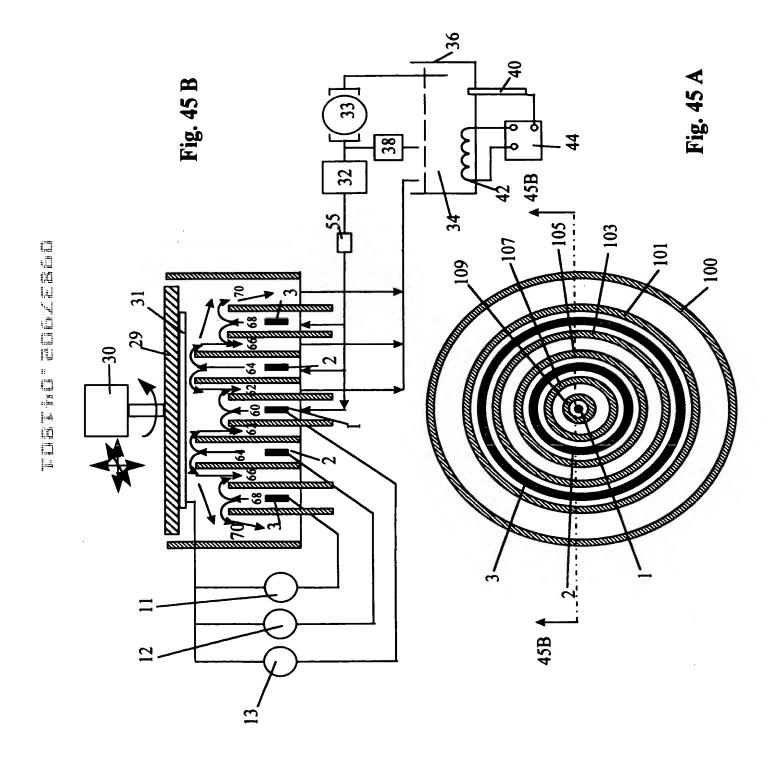
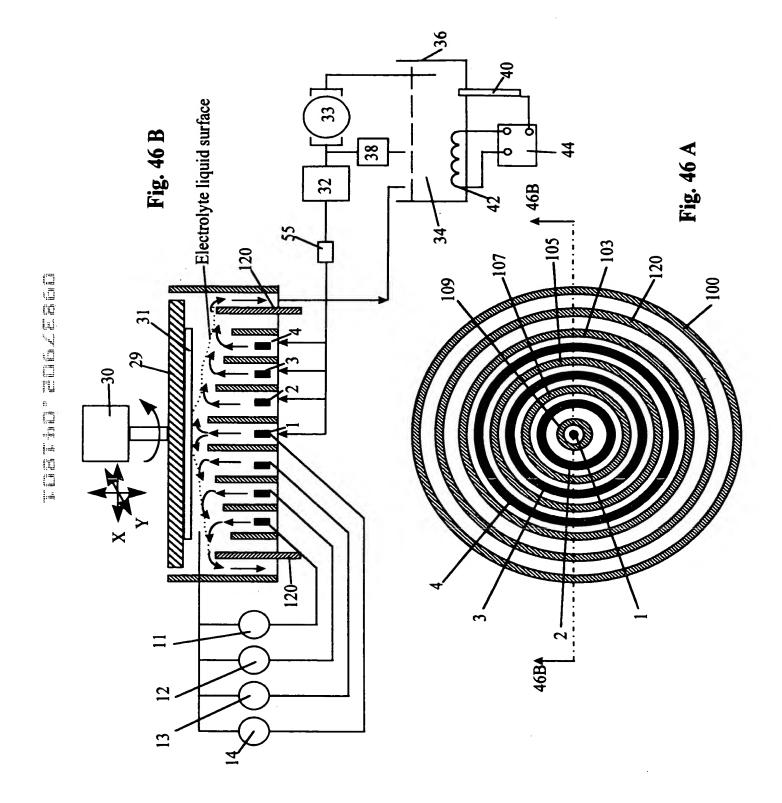
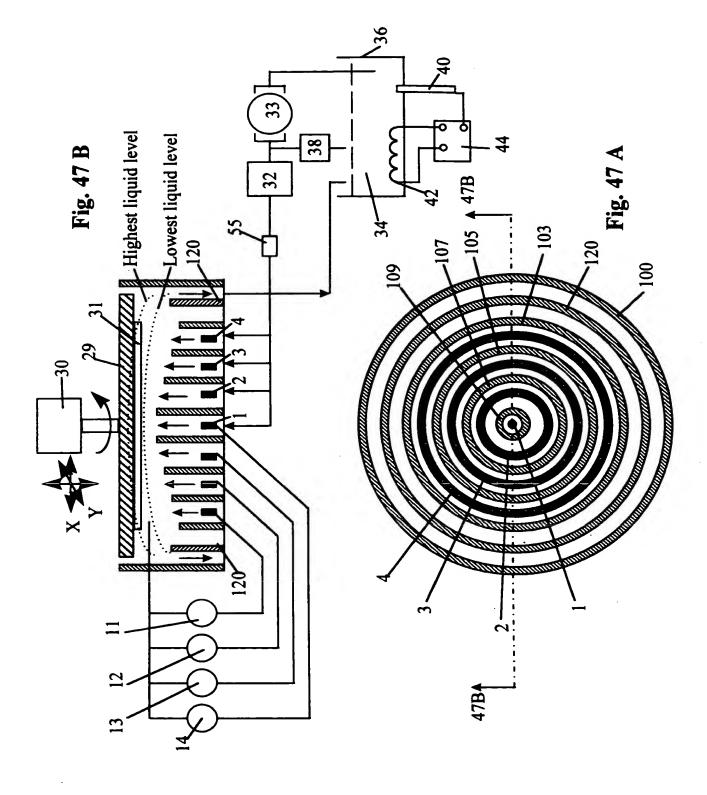


Fig. 43





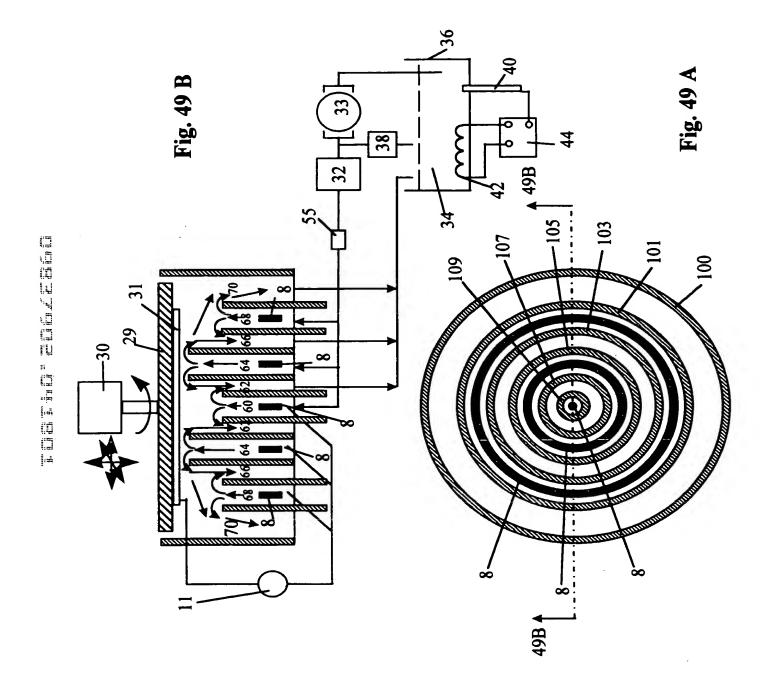




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Lowest wafer position Electrolyte liquid surface Highest wafer position 38 100 Fig. 48 A

Fig. 48 B



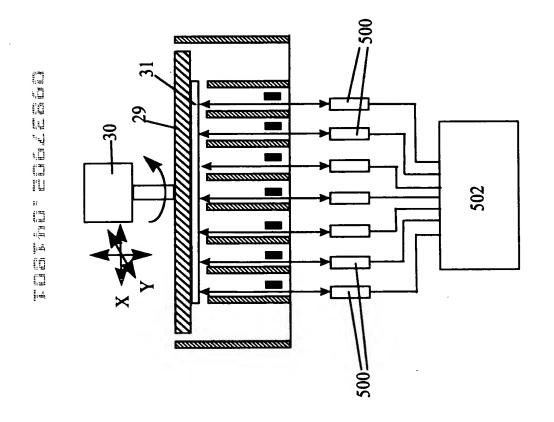


Fig. 50

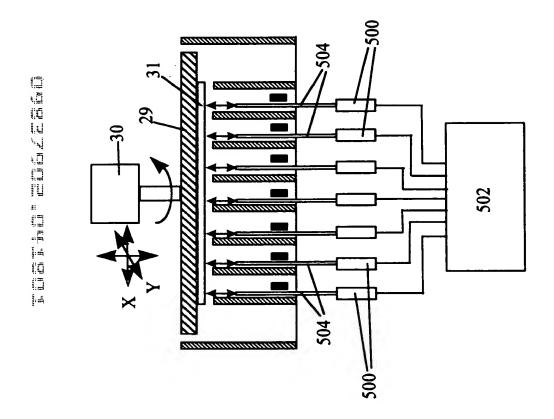
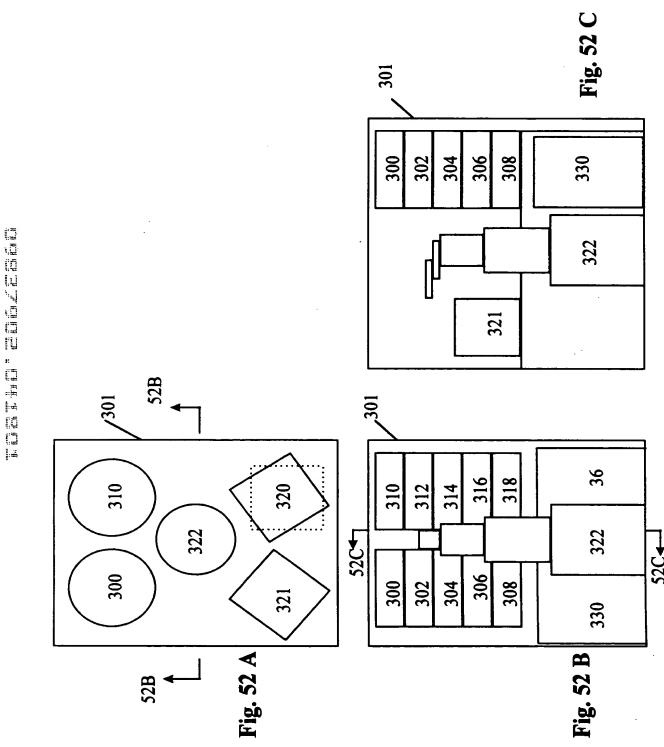


Fig. 5]



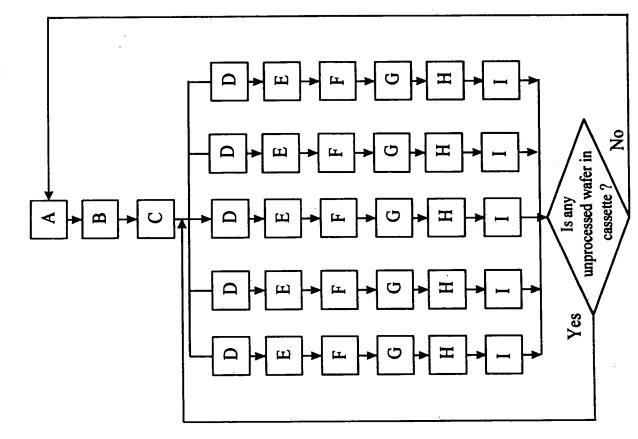
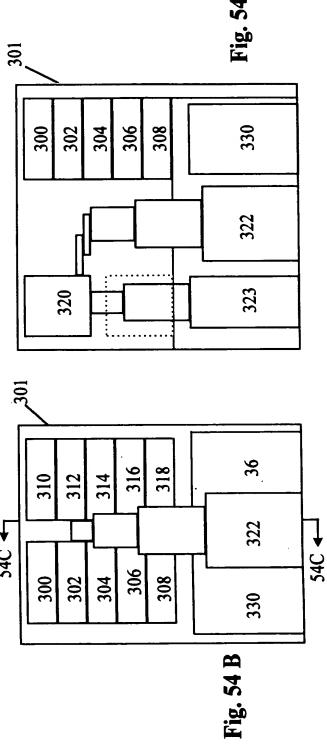
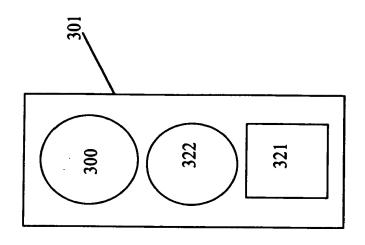


Fig. 54 A







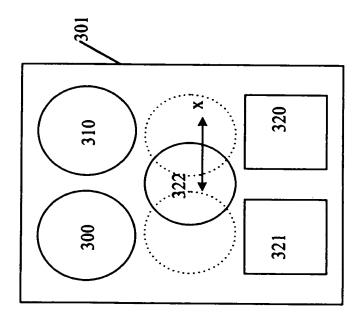
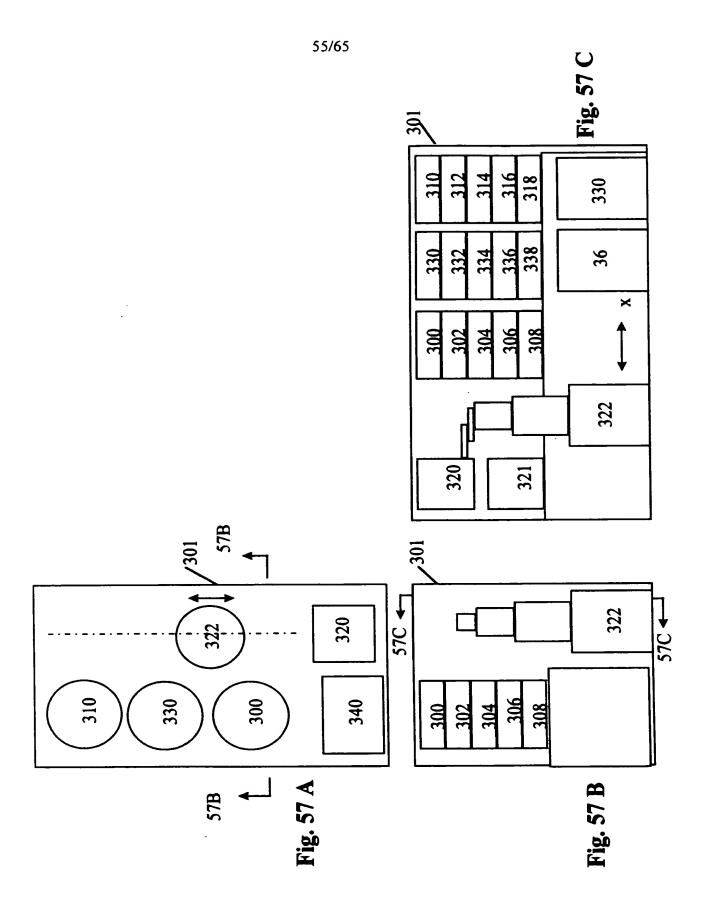
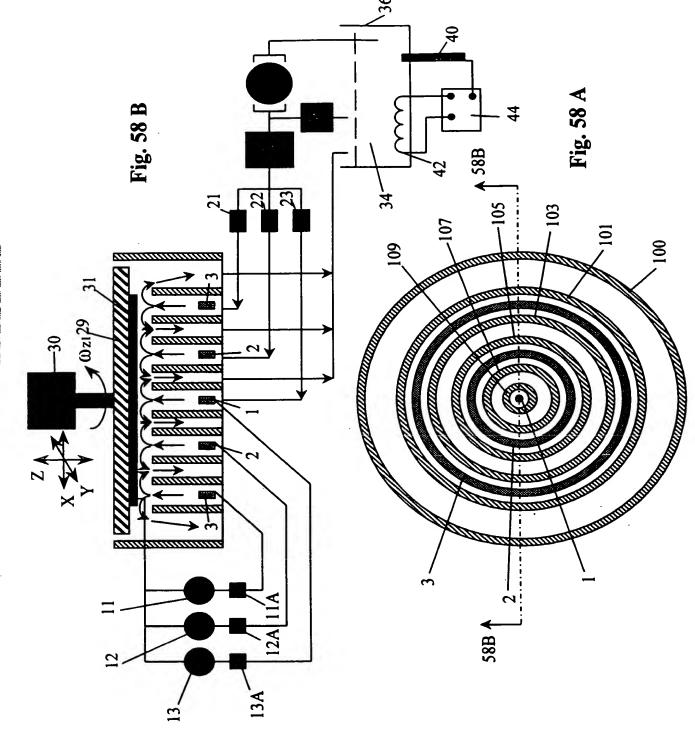


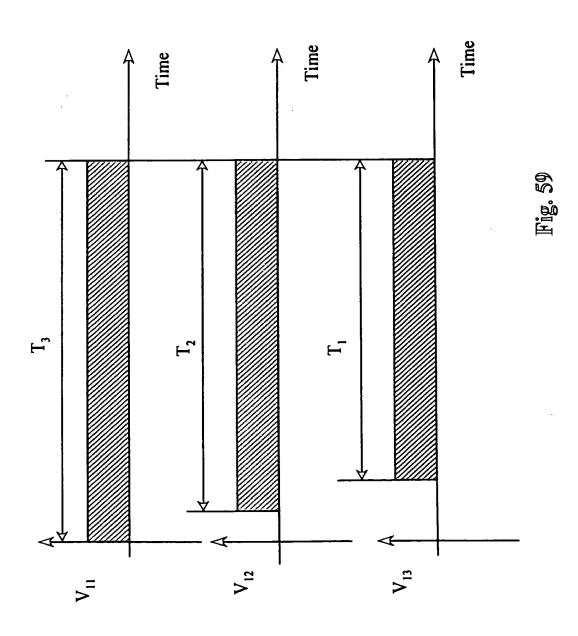
Fig. 5

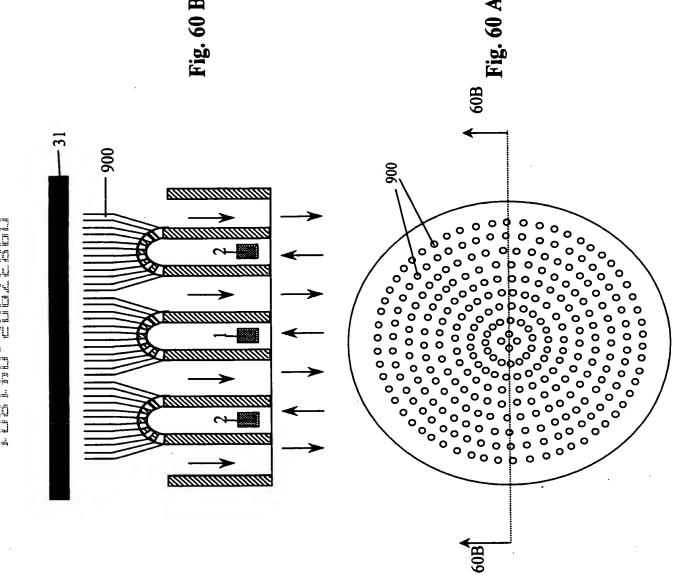


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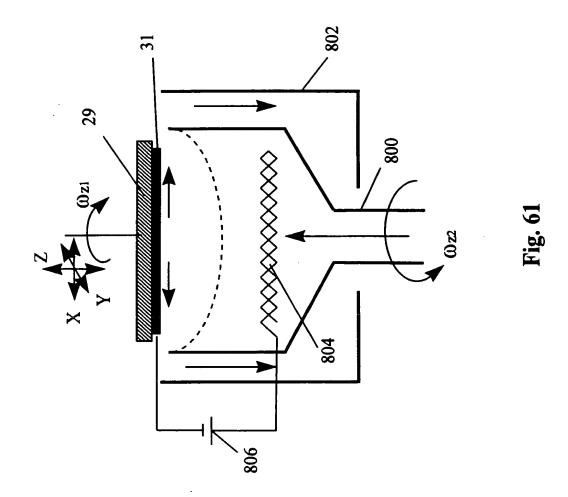


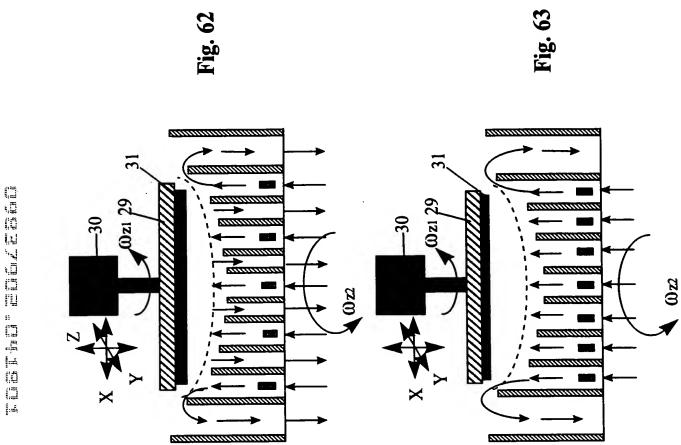
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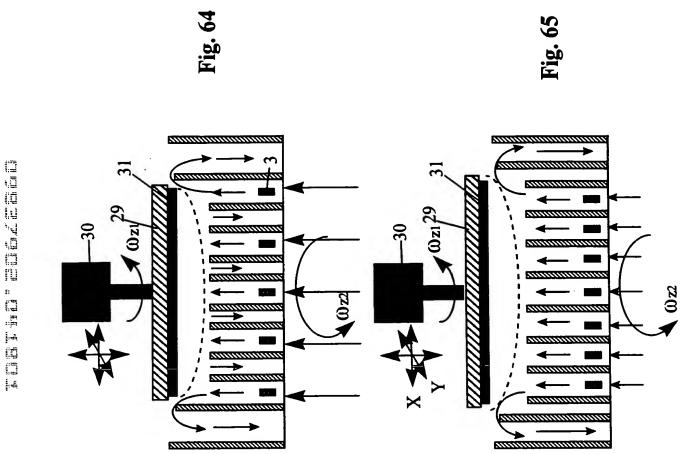




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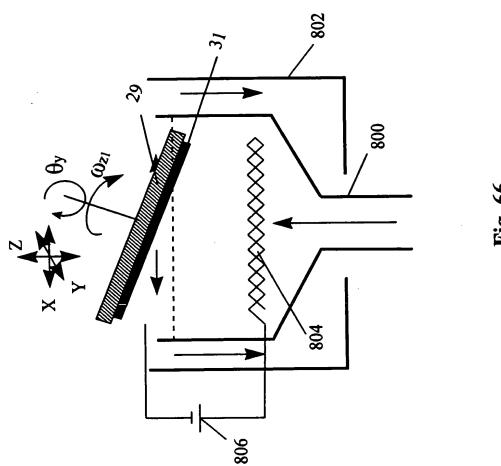
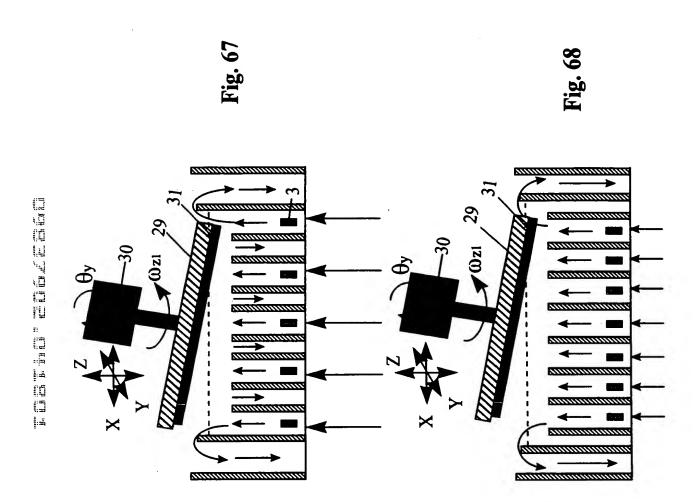
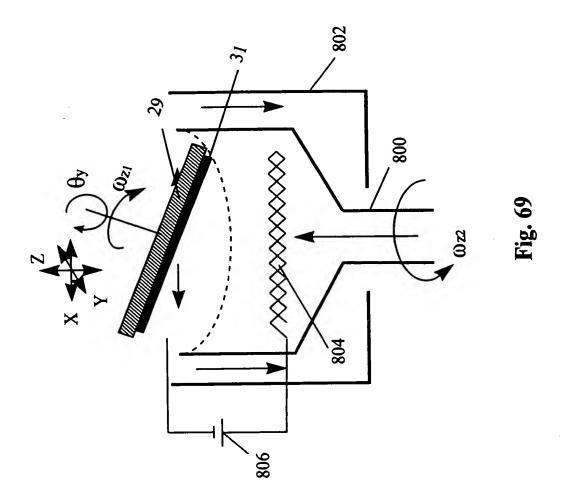
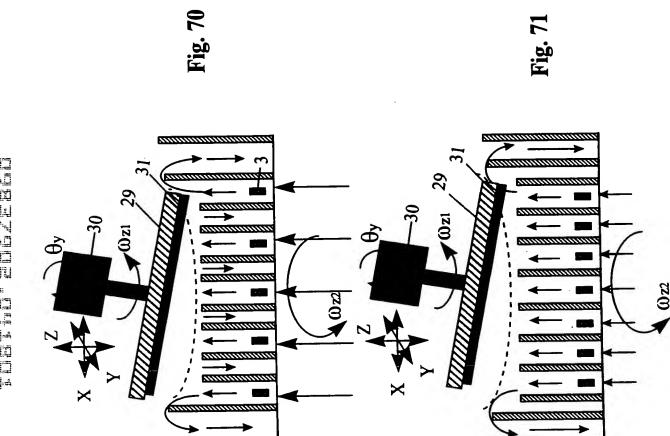


Fig. 66







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